

Efficient Multi-Barrier Thin Film Encapsulation of OLED Using Alternating Al₂O₃ and Polymer Layers

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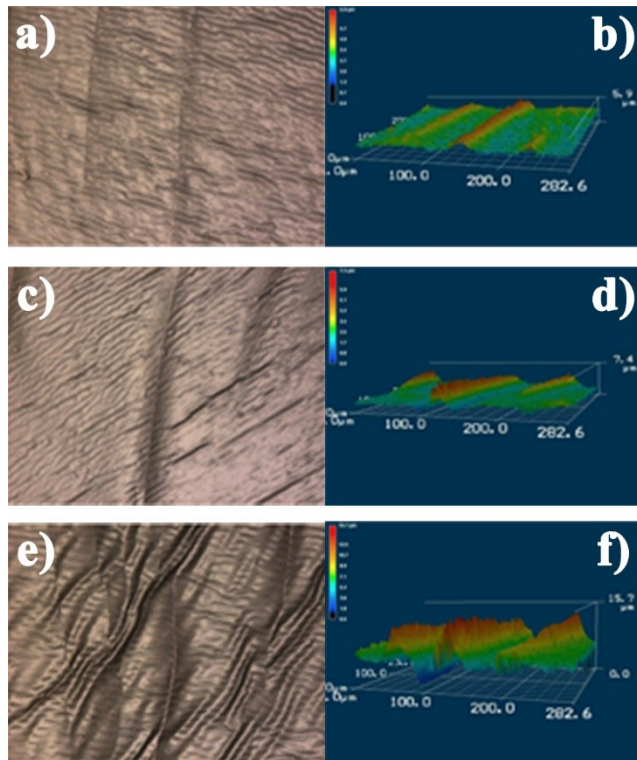


Fig. S1 Surface morphological characteristics of confocal laser scanning microscope with different structure of Al₂O₃/ parylene C (a) - and (b)-after repeatedly stretching of 15 nm Al₂O₃/250 nm parylene C, (c)- and (d)-after repeatedly stretching of 30 nm Al₂O₃/500 nm parylene C, (e)- and (f)-after repeatedly stretching of 50 nm Al₂O₃/500 nm parylene C.